DEPARTMENT OF COMMERCE ATTY. DOCKET NO. SERIAL NO. FORM PTO-1449 09/517,987 ATENT AND TRADEMARK OFFICE 94-C-096C2 (REV. 7.80) LIST OF REFERENCES CITED BY APPLICANT APPLICANT (Use several sheets if necessary) Kuei-Wu Huang, et al. **GROUP** FILING DATE March 3, 2000 2812 U. S. PATENT DOCUMENTS FILING DATE **SUBCLASS** CLASS DATE NAME *EXAMINER DOCUMENT NUMBER (if appropriate) INLIMAL Feb. 18, 1983 571 Fuls et al 4,450,620 May 29, 1984 29 571 Sep. 25, 1985 May 12, 1987 Maeda AB 4,663,825 643 Jun. 6, 1986 156 AC 4.676,867 Jun. 30, 1987 Elkins et al. 437 69 Jun. 3, 1987 Oct. 4, 1988 Szeto AD 4,775,644 Feb.21, 1989 357 59 ΑE 4,807,013 Feb. 21, 1989 Manocha Oct. 30, 1985 357 23.9 ΑF 4.841.347 Jun. 20, 1989 Hsu Jun. 25, 1987 437 45 Jul. 4, 1989 Holloway, et al AG 4,845,047 44 May 20, 1988 Aug. 22, 1989 437 AΗ 4,859,620 Wei et al 357 23.8 Jul. 27, 1987 Deslauriers et al. Jun. 26, 1990 ΑI 4,937,643 Apr. 13, 1989 229 437 Dec. 11, 1990 Haskell 4,977,108 437 228 Mar. 23, 1989 Jan. 28, 1992 Sakao 5,084,419 437 45 Oct. 31, 1990 Oct. 27, 1992 Hori et al 5,158,903 FOREIGN PATENT DOCUMENTS TRANSLATION COUNTRY CLASS **SUBCLASS** DOCUMENT NUMBER DATE YES NO χ 6/1985 H01L29 78 JP 60 103671 Japan AΜ H01L21 28 χ 9/1989 EP0 EP 0 334 761 A1 H01L21 336 Χ JP 02 009134 1/1990 Japan OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.) G. Quieirolo et al.. "Dpoant Activation, Carrier Mobility, and TEM Studies in Polycrystalline Silicon Films," J. Electrochem. Soc. vol. 37, no. 3, pp. 967-970 (March 1990). C.S. Pai et al. "Chemical Vapor Deposition of Selective Epitaxial Silicon Layers," J. Electrochem. So. vol. 137 no. 3, pp. 971-976 (March 1990). DATE CONSIDERED **EXAMINER**

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